



Docket No.: N0400.70013US00  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Edwin Lanier Piner  
Serial No.: 10/047455  
Confirmation No.: 1054  
Filed: January 15, 2002  
For: SEMICONDUCTOR STRUCTURES INCLUDING A GALLIUM  
NITRIDE MATERIAL COMPONENT AND A SILICON  
GERMANIUM COMPONENT  
Examiner: S. Hu  
Art Unit: 2811

**Certificate of Mailing Under 37 CFR 1.8(a)**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: 4/17/06

  
Signature

**TRANSMITTAL LETTER**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed are the following items for filing in connection with the above-referenced Patent Application:

1. Response to Office Action;
2. Request for Continued Examination;
3. Petition for Five (5) Month Extension of Time; and
4. Return Receipt Postcard.

Our check in the amount of \$1,475.00 covering the required fees is enclosed. The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 23/2825, under Docket No. N0400.70013US00. A duplicate copy of this paper is enclosed.

Dated: April 17, 2006

Respectfully submitted,

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